

# Verifire™

## QPZ

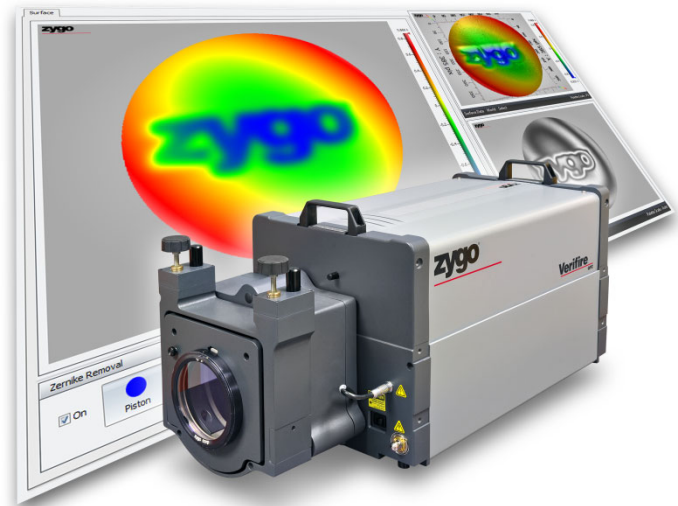
Fizeau interferometer with patented QPSI acquisition for true on-axis common path surface form metrology in the presence of vibration.

### SYSTEM OVERVIEW

Measurement Capability	Measures surface form of reflective materials and optics, and transmitted wavefront of transparent optics
Measurement Technique	QPSI rapid mechanical phase-shifting and traditional mechanical phase-shifting interferometry (PSI)
Alignment System	Quick Fringe Acquisition System (QFAS) with twin spot reticle
Test Beam Diameter	4 inch (102 mm) or 6 inch (152 mm)
Alignment FOV	4 inch: $\pm 3$ degrees 6 inch: $\pm 2$ degrees
Optical Centerline	4.25 in. (108 mm)
Laser Source	High power stabilized HeNe, Class IIIa
Wavelength	633 nm
Frequency Stabilization	$< 0.0001$ nm
Coherence Length	$> 100$ m
Camera Resolution	640 x 480 pixels
Camera Frame Rate	210 Hz (PSI) 50 $\mu$ s – 5 ms (QPSI)
Acquisition Time	62 ms (PSI); 143 ms (QPSI/30 frame)
Digitization	8 bits
Magnification	1-6x motorized
Polarization	Nominally circular (1.2:1 or better)
Pupil Focus Range	4 inch: $\pm 2.5$ m 6 inch: $\pm 5.5$ m
Computer and Software	High-performance Dell PC, Windows 7 64-bit, MetroPro™9 and MetroPro X software <sup>1</sup>
Mounting Configuration	Horizontal or vertical
Accessories	See the ZYGO <i>Laser Interferometer Accessory Guide, OMP-0463</i>
Physical Envelope (LWH)	4 inch: 69 x 31 x 34 cm (27.3 x 12.1 x 13.4 in.) 6 inch: 92 x 31 x 34 cm (36.4 x 12.1 x 13.4 in.)
Weight	4 inch: $\leq 85$ lb (38 kg) 6 inch: $\leq 100$ lb (45 kg)
Power	100 to 240 VAC, 50/60 Hz

### OPERATIONAL ENVIRONMENT<sup>(2)</sup>

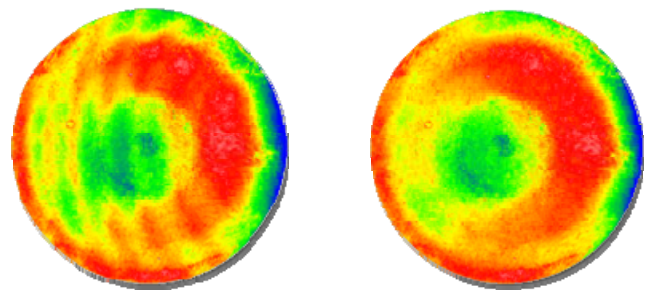
Temperature	15 to 30°C (59 to 86°F)
Rate of Temp. Change	$< 1.0^\circ\text{C}$ per 15 min
Humidity	5 to 95% relative, non-condensing
Vibration Isolation	QPSI enables metrology in environments with vibrations of a magnitude of up to $\sim 150$ nm. A passive isolation system is recommended with PSI acquisition.



### PERFORMANCE

RMS Simple Repeatability <sup>3</sup>	$< 0.06$ nm, $\lambda/10,000$ ( $2\sigma$ )
RMS Wavefront Repeatability <sup>4</sup>	$< 0.35$ nm, $\lambda/1,800$ (mean + $2\sigma$ )
Peak Pixel Deviation <sup>5</sup>	$< 0.5$ nm, $\lambda/1,200$ (99.5 <sup>th</sup> %)

### Comparison of acquisitions in vibrating cavity



PSI 13 bucket algorithm

QPSI 5 ms shutter speed

### Notations

- 1 QPSI acquisition is only available on MetroPro X software.
- 2 These parameters outline the conditions under which the system can operate; they do not represent the environmental stability required to meet specified performance
- 3 RMS Simple Repeatability is defined by 2X the standard deviation of the RMS for 36 sequential measurements (16 averages) of a short 4 inch plano cavity.
- 4 RMS Wavefront Repeatability is defined by the mean RMS difference plus 2X the standard deviation for the differential between all even numbered measurements and a synthetic reference (defined as the average of all odd numbered measurements); 36 sequential measurements (16 averages) form the basis for calculation.
- 5 Peak Pixel Deviation is defined by the 99.5<sup>th</sup> percentile of the pixel-wise standard deviation map for 36 sequential measurements (16 averages); this result measures time varying behavior (or Type A uncertainties).



Specifications subject to change without notice

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